

APPENDIX A

Title: Method of Fabricating a Memory Device Having a Self-Aligned Contact;
Applicant: Chiu et al.; Application No.: 10/714,128; Attorney Docket No.: P910188.

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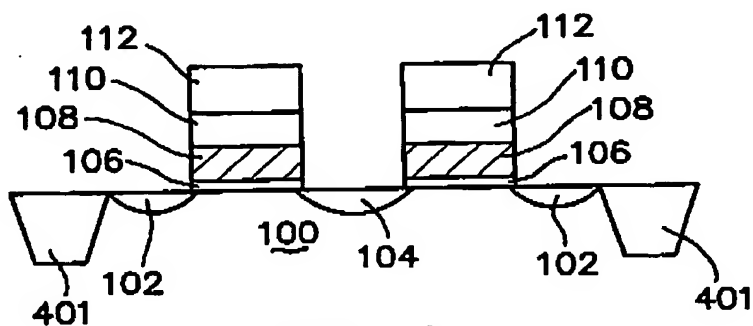


FIG. 1

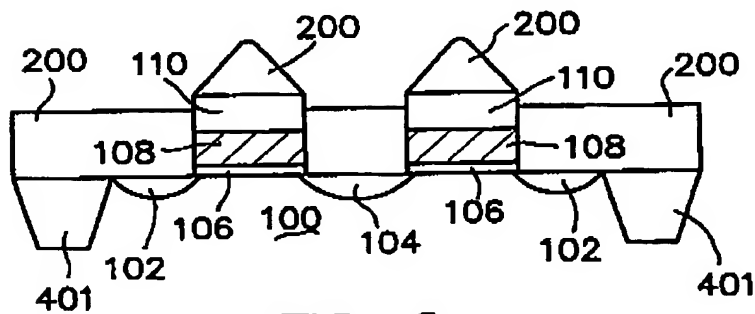


FIG. 2

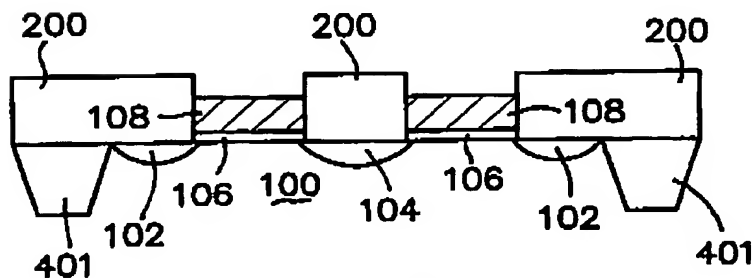


FIG. 3

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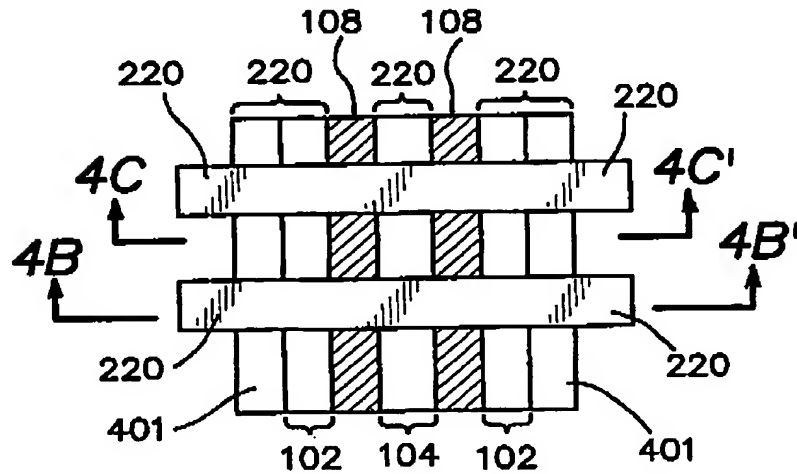


FIG. 4A

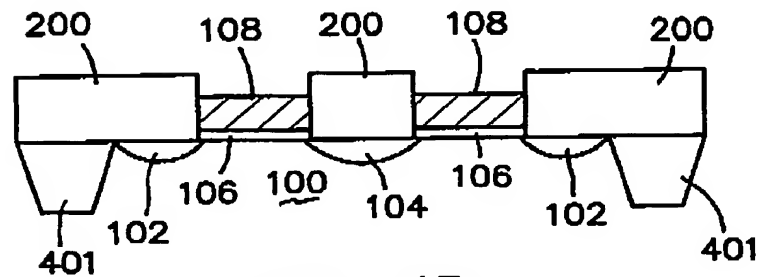


FIG. 4B

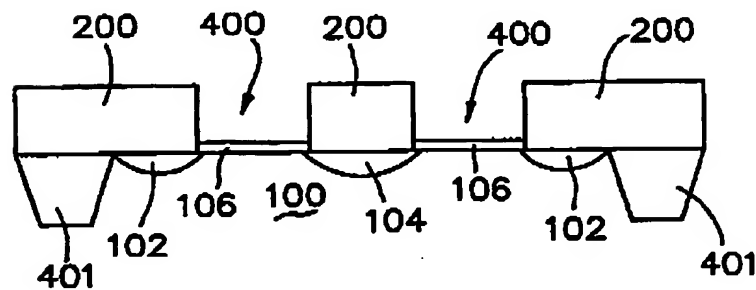


FIG. 4C

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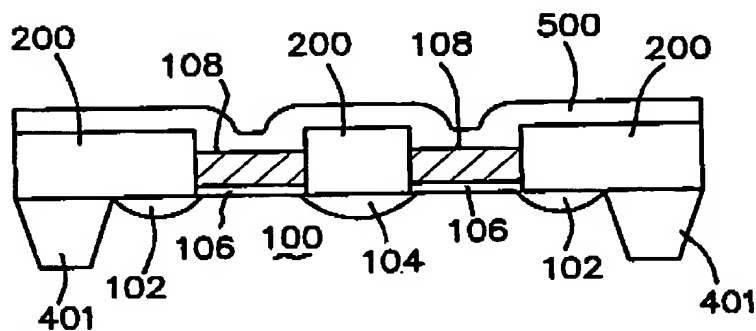


FIG. 5A

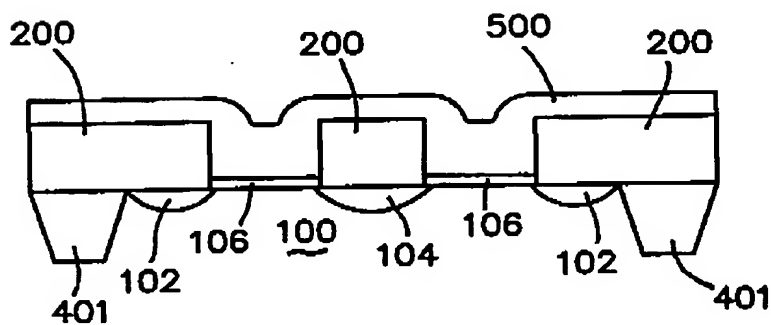


FIG. 5B

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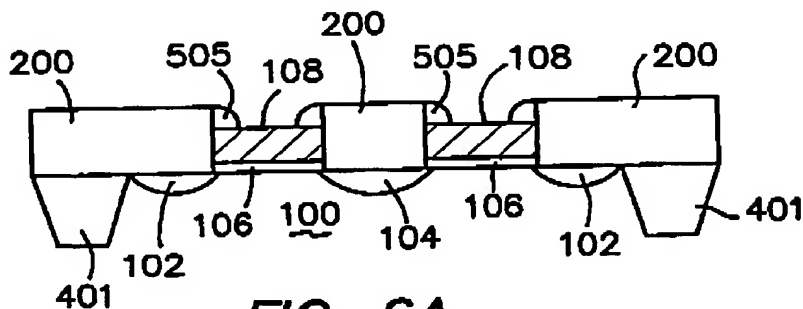


FIG. 6A

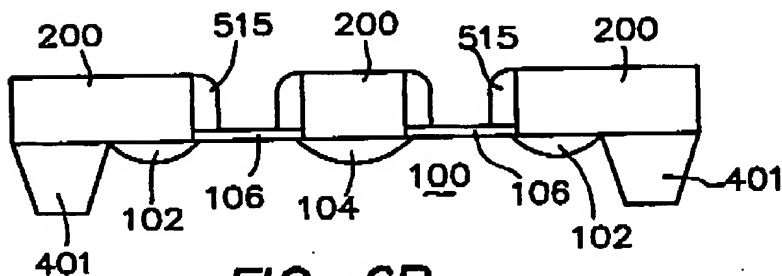


FIG. 6B

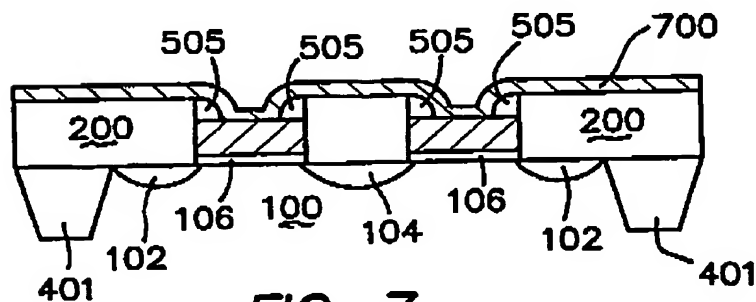


FIG. 7

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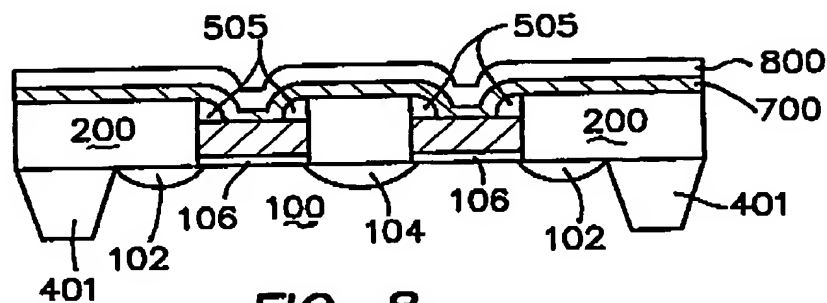


FIG. 8

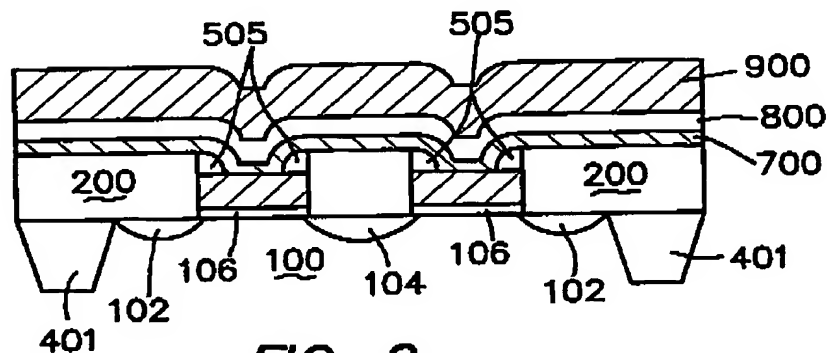


FIG. 9

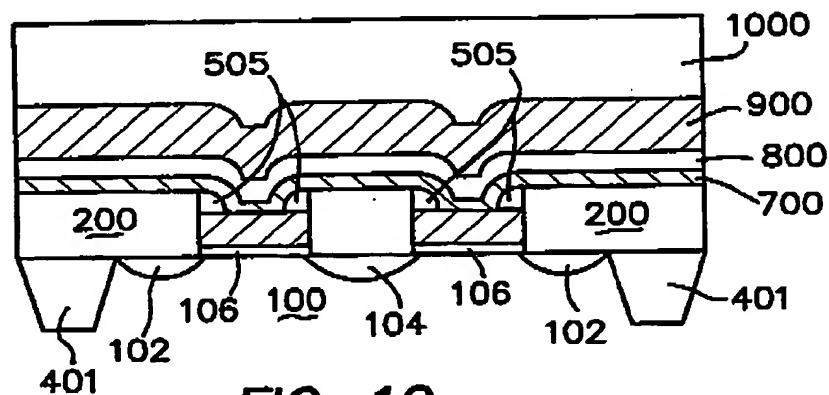


FIG. 10